

In re: Tsumori et al.
Serial No.: 10/646,500
Filed: August 22, 2003
Page 2

In the Claims:

1. (Original) A plated substrate adapted for hard disk medium comprising
a Si single crystal substrate;
an amorphous layer on the substrate, the amorphous layer having thickness of 2 to 200nm
and containing Si and one or more metals selected from a group consisting of Ni, Cu and Ag; and
a multicrystal layer on the amorphous layer, the multicrystal layer having thickness of 5 to
1000nm and containing Si and one or more metals selected from a group consisting of Ni, Cu and
Ag.
2. – 5. (Cancel)